EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(micro near (machine or machining or machined)) and wavelength and (micro near (optical or optic or optics)) and laser and ((align or aligned or alignment) near camera) and pixel	USOCR	OR	ON	2006/03/04 22:30
L2	0	(micro near (machine or machining or machined)) and wavelength and (micro near (optical or optic or optics)) and laser and ((align or aligned or alignment) near camera) and pixel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/04 22:30
L3	0	(micro near (machine or machining or machined)) and wavelength and (micro near (optical or optic or optics)) and laser and ((align or aligned or alignment) near camera)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/04 22:30
L4	64	(micro near (machine or machining or machined)) and wavelength and (micro near (optical or optic or optics)) and laser and (align or aligned or alignment) and pixel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/04 22:31
L5	47	(micro near (machine or machining or machined)) and wavelength and (micro near (optical)) and laser and (align or aligned or alignment) and pixel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/04 22:31
L6	27	(micro near (machine or machining or machined)) and wavelength and (micro near (optical)) and laser and (align or aligned or alignment) and pixel and ((sub near micron) or submicron)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/04 22:32
L7	1	(micro near (machine or machining or machined)) and wavelength and (micro near (optical)) and laser and (align or aligned or alignment) and pixel and ((sub near micron) or submicron) and preform	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/04 22:33